

<b>Notice of References Cited</b>		Application/Control No. 10/530,532	Applicant(s)/Patent Under Reexamination YAMADA, RITSUKO	
		Examiner David Buttner	Art Unit 1712	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,703,086	10-1987	Yamamoto et al.	525/133
	B	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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